



# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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Document Number (Optional)

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Application Number

10/798,558

Applicant

Yu-Hui Lu et al.

Filing Date

03/11/04

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## U. S. PATENT DOCUMENTS

MA	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	NUMO DATE IF APPROPRIATE
MA	445780	3/7/84	Takigawa	156	626	12/8/82
MA	3988564	10/26/76	Garvin et al.	219	121 EM	6/14/74
MA	5945677	8/31/99	Leung et al.	250	396R	1/5/99
MA	6514866	2/4/03	Russell et al.	438	712	5/31/01
MA	5683547	11/4/97	Azuma et al.	156	643.1	7/12/94
MA	6528818	3/4/03	Satya et al.	257	48	8/25/00
MA	6538844	3/25/03	Takano et al.	360	122	2/27/02
MA	5616921	4/1/97	Talbot et al.	250	307	6/30/94

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
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## OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)


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